

In re Application of:

Docket No. 03500.016072.1

MINEO SHIMOTSUSA, ET AL.

Application No.: 10/657,269

Filed: September 9, 2003

For: SEMICONDUCTOR DEVICE,

METHOD FOR MANUFACTURING

THE SAME, AND LIQUID JET APPARATUS

Examiner: Unassigned

Group Art Unit: 2811

Date: March 31, 2004

Mail Stop Non-Fee Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a Second Preliminary Amendment in the above-identified application.

X No additional fee is required.

The fee has been calculated as shown below

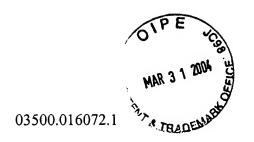
CLAIMS AS AMENDED							
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE	
TOTAL CLAIMS	34	MINUS	34	= 0	x \$9 \$18	\$ 0.00	
INDEP. CLAIMS	7	MINUS	7	= 0	x \$43 \$86	\$ 0.00	
Fee for Multiple Dependent claims \$145°/\$290							
	\$ 0.00						

	Verified Statement claiming small entity status is enclosed, if not filed previously.					
	A check in the amount of \$ is enclosed.					
	Charge \$ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.					
X	Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06 1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.					
	A check in the amount of \$ to cover the fee for a month extension is enclosed.					
	A check in the amount of \$ to cover the Information Disclosure Statement fee is enclosed.					
X	Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.					
	Respectfully submitted,					
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Attorney for Applicants Damond E. Vadnais Registration No. 52,310

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza
New York, New York 10112-3800
Facsimile: (212) 218-2200
DEV/vc

Form #120



## **PATENT APPLICATION**

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	Examiner: Unassigned	
MINEO SHIMOTSUSA, ET AL.	)	Group Art Unit: 2811	
Application No.: 10/657,269		Gloup Art Offit. 2811	
Filed: September 9, 2003	)		
For: SEMICONDUCTOR DEVICE, METHOD FOR MANUFACTURING THE SAME, AND LIQUID JET APPARATUS	; ; ) :	March 31, 2004	
N. C. C. St. D. A I			

Mail Stop Non-Fee Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## SECOND PRELIMINARY AMENDMENT

Sir:

Preliminary to examination, please amend the above-identified application,

as follows: